TITLE OF INVENTION: INSPECTION APPARATUS FOR ELECTRONIC COMPONENT PROCESSING EQUIPMENT

ABSTRACT

Disclosed herein is an inspection apparatus for electronic component processing equipment. The inspection apparatus includes: a laser radiator provided to radiate long linear laser in one direction onto the top surfaces of electronic components loaded onto a loading element; a reflector configured to reflect the laser, radiated by the laser radiator, to the top surfaces of the electronic components; a checking camera configured to photograph the laser reflected to the top surfaces of the electronic components by the reflector; a mounting bracket provided to mount the reflector; and a controller configured to analyze the seating states of the electronic components by analyzing an image taken by the checking camera. The mounting bracket has a close contact portion configured to bring the reflector into close contact with the flat close contact surface of the mounting bracket by pressing the reflector toward the flat close contact surface.

[FIG. 4]